



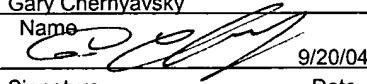
PATENT
81716.0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Isamu AKASAKI et al.
Serial No: 10/810,309
Filed: March 26, 2004
For: Semiconductor Apparatus, Method for
Growing Nitride Semiconductor and Method
for Producing Semiconductor Apparatus

Art Unit: 2811

Examiner: Not assigned

I hereby certify that this correspondence
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September 20, 2004
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Name

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9/20/04
Date

PETITION FOR EXTENSION OF TIME

Mail Stop Missing Parts
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Dear Sir:

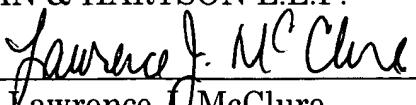
In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a two-month extension of time extending to October 7, 2004, the period for response to the Notice to File Missing Parts of Application dated June 7, 2004. The check in the amount of \$420.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: September 20, 2004

By: 
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Registration No. 44,228
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